ON 5 2003 E IN PHE LIMITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Kenichi HIGUCHI

Serial No.: 10/654,979 Group Art Unit: UNASSIGNED

Filed: September 5, 2003 Examiner: UNASSIGNED

For: METHOD FOR ETCHING ORGANIC INSULATING FILM AND METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.97(b)(4)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

December 5, 2003

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits in the above-identified patent application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a) concerning the PTO duty to consider and use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 50-2866 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Stephen G. Adrian Attorney for Applicants Reg. No. 32,878

Enclosures: PTO-1449; and 1 reference

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DEC 0 5 2003 Atty. Docket No. 031110 INFORMÂŢĮON Serial No. 10/654,979 DISCLOSURE Applicant(s): Kenichi HIGUCHI **CITATION** PTO-1449 Group Art Unit: Unassigned Filing Date: September 5, 2003 **U.S. PATENT DOCUMENTS Filing Date** Subclass Document No. **Date** Class **Examiner** Name Initial (If appropriate) $\mathbf{A}\mathbf{A}$ AB FOREIGN PATENT DOCUMENTS Translation Country Examiner Document No. **Date** (Yes or No) Initial Japan **Abstract** 04/2001 AC2001-110784 AD \mathbf{AE} **AF** AG AH ΑI **OTHER DOCUMENTS** AJ A K

Date Considered

Examiner